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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re

U.S. Application of:

Kenji NAKAMURA

For:

CAMERA WITH MULTIPLE USE CIRCUITRY

Confirmation No:

1740

U.S. Serial No.:

09/821,442

Filed:

March 29, 2001

Group Art Unit:

2612

Examiner:

Trung Luong Nguyen

MAIL STOP AF

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP AF, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on

> July 1, 2005 Date of Deposit

MICHAEL J. DEHAEMER, Jr.

Name of Applicant, Assignee, or Registered

Representative

Signature

July 1, 2005 Date of Signature

Dear Sir:

<u>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT</u> <u>UNDER 37 C.F.R. §1.97(e) AND §1.98</u>

In compliance with the duty of disclosure set forth in 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicant wishes to bring the following items to the attention of the Examiner. A copy of each document is enclosed for the convenience of the Examiner.

No representation is made, and no representation is intended, that more relevant material does not exist, or that the order of presentation of this material in any way reflects its relative pertinence. Specifically, this presentation is not an admission that the items listed below are properly citable against the above-identified application.

Serial No. 09/821,442

Submitted herewith:

- (1) "Japanese" Notice on Reasons for Rejection, dated June 7, 2005, for counterpart Japanese Patent Application No. 2000-097389, along with an English translation thereof.
- (2) Japanese Published Unexamined Patent Application (A) 2000-050116 (CASIO COMPUT CO LTD), published February 18, 2000;
- (3) Japanese Published Unexamined Patent Application (A) 10-210424 (SONY CORP), published August 7, 1998;
- (4) Japanese Published Unexamined Patent Application (A) 2000-050148(HITACHI DENSHI LTD), published February 18, 2000;
- (5) Japanese Published Unexamined Patent Application (A) 06-217175 (OLYMPUS OPTICAL CO LTD), published August 5, 1994;
- Japanese Published Unexamined Patent Application (A) 2000-041207(CANON INC), published February 8, 2000; and
- (7) Japanese Published Unexamined Patent Application (A) 10-079888(MINOLTA CO LTD), published March 24, 1998.

No copy of Document (4) is provided as this document was included in the Information Disclosure Statement filed on May 25, 2001.

The Japanese Patent Application Laid-Open Nos. (A) 2000-050116 reference (2), (A) 10-210424 reference (3), (A) 2000-050148 reference (4), (A) 06-217175 reference (5), (A) 2000-041207 reference (6), and (A) 10-079888 reference (7) above, are cited in the item (1), "Notice of Reasons for Rejection", which indicates the degree of relevance found by the foreign office.

Serial No. 09/821,442

In accordance with 37 CFR § 1.97(e), it is hereby certified that each item of information contained in this Supplemental Information Disclosure Statement is being filed within three months of being first cited in a foreign communication in a counterpart foreign application. As this Supplemental Information Disclosure Statement is being filed after the mailing of the final Office Action under § 1.113, but before the receipt of a Notice of Allowance under § 1.311, whichever occurs first, the required fee of \$180.00 under 37 C.F.R. § 1.97(c)(2) for the submission of the Supplemental Information Disclosure Statement should be charged to Sidley Austin Brown & Wood LLP's Deposit Account No. 18-1260. Please credit any overpayment to Deposit Account No. 18-1260. The Supplemental Information Disclosure Statement (three pages) is being filed in duplicate.

Respectfully submitted,

Michael J. DeHaemer, Jr. Registration No. 39,164 Attorney for Applicant

MJD/rb SIDLEY AUSTIN BROWN & WOOD LLP 717 North Harwood Suite 3400 Dallas, Texas 75201-6507 (214) 981-3335 (direct) (214) 981-3300 (main) (214) 981-3400 (facsimile) July 1, 2005

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Substitute for form 1449A/PTO JUL 1 1 2003 E							irmation No.	1740		
SUPPLEMENTALY INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Filing Date		March 29, 2001		
						First Inventor		Kenji NAKAMURA		
						Group Art Unit		2612		
						Exam	niner Name	Trung Luc	ong Nguyen	
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				U.S. P	ATENT	DOC	UMENTS			
Examiner Initials	Cite #		IMENT IBER	C O D E	PATENT	ree	ISSUE DATE (mm/dd/yy)	CLASS	SUB CLASS	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS

Examiner Initials		O F F I C	NUMBER	C O D E	PUBLICATION DATE (mm/dd/yy)	TRANSLATION Yes No
	(2)	JP	2000-050116	Α	02/18/2000	ABSTRACT ONLY
-	(3)	JP	10-210424	Α	08/07/1998	ABSTRACT ONLY
	(5)	JP	06-217175	Α	08/05/1994	ABSTRACT ONLY
	(6)	JP	2000-041207	Α	02/08/2000	ABSTRACT ONLY
	(7)	JP	10-079888	• А	03/24/1998	ABSTRACT ONLY

NON PATENT LITERATURE DOCUMENTS

Examiner Initials Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (b symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country to the symposium of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (b symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country to the symposium of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (b symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country to the symposium of the author (in CAPITAL LETTERS).			le (when appropriate), title of the item (book, magazine, journal, serial, umber(s), publisher, city and/or country where published					
	(1)	"Japanese" Notice on Reasons for Rejection, dated June 7, 2005, for counterpart Japanese Patent Application No. 2000-097389, along with an English translation thereof						
Examine	r		Date					
Signature			Considered					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with the next communication to applicant.